



EFK

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76454

Shinji YOKONO, et al.

Appln. No.: 10/611,961

Group Art Unit: 1762

Confirmation No.: 3574

Examiner: James Lin

Filed: July 3, 2003

For: METHOD FOR MANUFACTURING PLASMA DISPLAY PANEL, INSPECTION
METHOD FOR INSPECTING PHOSPOR LAYER AND INSPECTION APPARATUS
FOR INSPECTING PHOSPHOR LAYER

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This responds to the Restriction Requirement, dated June 26, 2006. In response to the Restriction Requirement, Applicants elect Group I, claims 1-8 for examination. This election is made with out traverse.

Applicants reserve the right to file a Divisional Application directed to non-elected claims 9-14.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

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CUSTOMER NUMBER

Date: July 26, 2006